

Docket No.: 1794-0141P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Yoshinobu AOYAGI et al.

Application No.: 09/941,612

Confirmation No.: 6758

Filed: August 30, 2001

Art Unit: 1792

For: IMPURITY DOPING METHOD FOR
SEMICONDUCTOR AS WELL AS SYSTEM
THEREFOR AND SEMICONDUCTOR
MATERIALS PREPARED THEREBY

Examiner: M. J. Song

AMENDMENT AFTER FINAL OFFICE ACTION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Madam:

INTRODUCTORY COMMENTS

In response to the Examiner's Office Action dated December 23, 2008, the period for response having been extended three (3) month to June 23, 2009, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application.

This reply includes

Amendments to the Claims; and

Remarks.